

United States Patent [19]

Iwamura et al.

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| [54] | PLASMA TREATMENT APPARATUS AND |
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| | METHOD |
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| 41 | A D | DI. IN | O.: 3 | 98,082 |

| [30] | Fore | eign A | Applicati | ion | Priority | Data |
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| Feb. 7. | 1995 | IJPl | Japan | | ************ | |

| , | 1995 [JP] 1995 [JP] | Japan 7-01 Japan 7-34 | |
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| [51] In t | t. Cl. ⁶ | B23K 1 | 10/00 |
| [52] U.S | S. Cl | 219/121.43 ; 219/12 | 1.44; |
| | | 219/121.51; 156/345; 156/6 | 546.1 |
| | | | |

219/121.4, 121.59, 121.52, 121.51; 156/345, 643.1; 204/298.34, 298.06, 192.1, 298.37,

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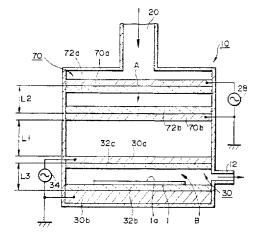
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ABSTRACT

A plasma treatment and apparatus which enables improved uniform plasma treatment over the entire surface of an object to be treated, improved yield, and higher treatment speed is provided. In a gas introduction passage, the gas capable of plasma discharge is preexcited to raise its level of excitation. A first pair of plasma generation electrodes downstream along the gas flow passage use the preexcited gas to generate a plasma in a first plasma generation position. Further downstream, a second pair of plasma generation electrodes positioned in a second plasma generation position, where the activated state of the gas activated in the first plasma region is maintained, activates the gas to generate a plasma containing activated gas species. The object to be treated is treated by the activated gas species in the second plasma region.

37 Claims, 9 Drawing Sheets





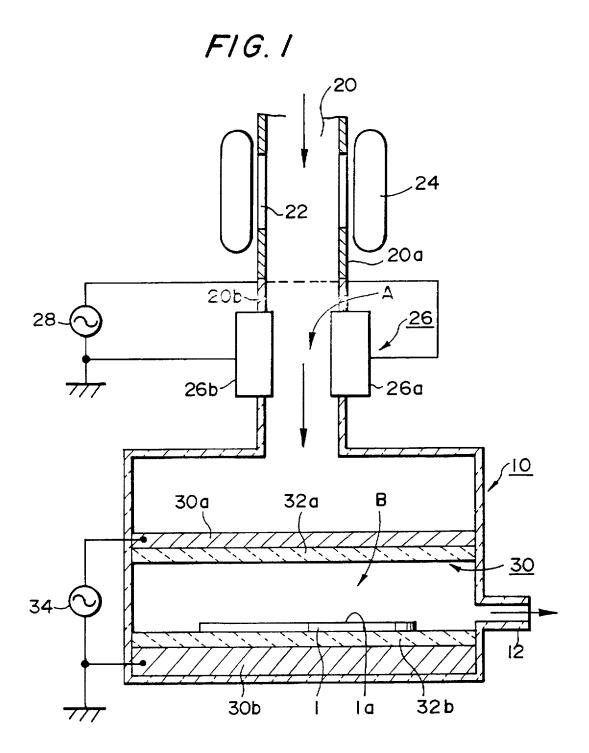
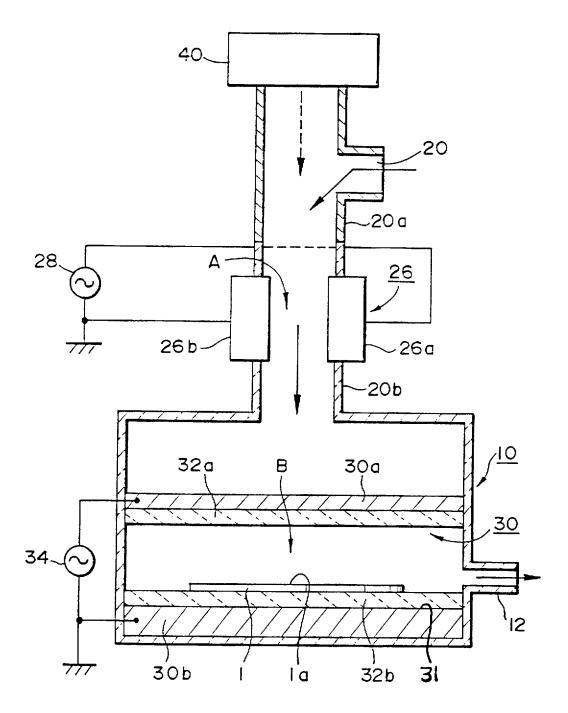


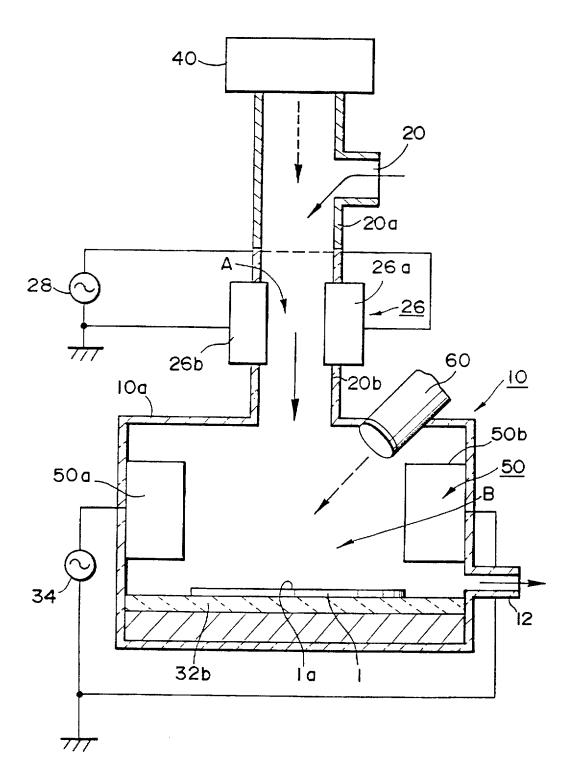


FIG. 2



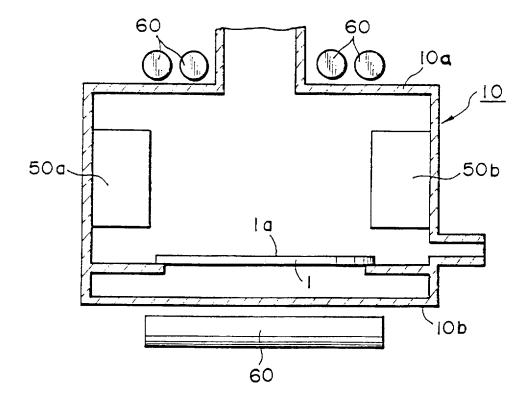








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